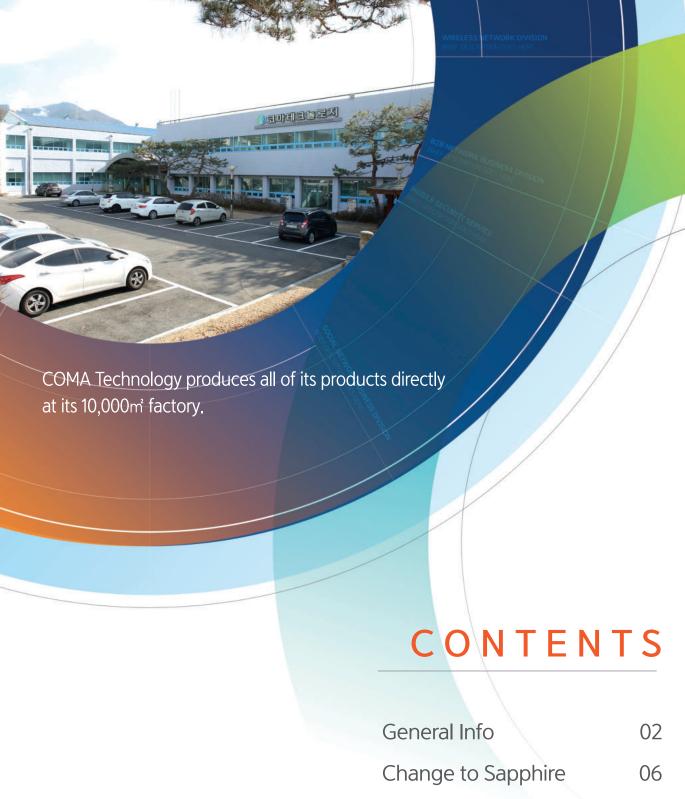
COreMAterial . Technology



COMA Technology



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A Company to create a new structure in the Global Market of Semiconductor Industry.

Opening the Future of Semiconductor Industry with COMA Technology.



We have a whole process line for production, Especially for the Post-treatment Process Like Lapping, Polishing, Etching, Cleaning and Packing In the 10~1,000 Class Clean Room.

Hello, this is from Sung-hoon Park, President/CEO of COMA Technology Co., Ltd. a specialized company in semiconductor equipment materials and parts.

Global Specialized Material/Part Company

COMA Technology Co., Ltd., since its inception in January 2013 starting with manufacture and lapping/polishing of parts of sapphire and ceramic, has grown up to be a specialized company in parts and materials of various high functional sapphire and ceramic for semiconductor, display, defense and medical industry machines, etc.

Especially in manufacture of industrial sapphire parts COMA has the top level of machining, lapping, polishing and surface finish technology in Korea and through incessant R&D investment it continues to newly bring out such matchless unique technologies as bonding, micro machining, etc.

COMA Technology Co., Ltd., without resting on our present achievements, will be prepared for the new era through development of new materials and parts, development of new products for cost reduction and yield enhancement, diversification of exports, and innovative creation of markets which haven't existed so far, etc. and fulfill social responsibility to become an everlasting company, contributing to making the world of abundance, the world good to live in and the world where all can live well together. Your deep interest and encouragement will be highly appreciated.

Thank you!

Sung-hoon Park, President/CEO, COMA Technology Co., Ltd.

2013~2014

2015~2016

201

2014

July Obtained ISO9001 (International

Quality Management) Cetification

April Established Certified Company

Affiliated Underresearch

Institute

January Moved First Building to

Gwangju , Gyeonggi-do

2013

November Certified Technology

Venture Fund

September Developed Aluminium

Reflector

for K-1 Armoured Vehicle

July Developed Porous Ceramic

Vacuum Chuck

May Sapphire Surface Processing

Technology Development

February Established Coma Technology

Corporation

2016

December Participated in Semicon Japan(Tokyo)

Exhibition

July Certified as Innobiz Company

May Attracted Investment from

Attracted Investment from Technology Gurantee Fund

January HDP CVD Equipment, Development and Mass Production of Sapphire

Side Nozzle

2015

December Development Of Etching Process

for Sapphire and Double Joint Nozzle

December Development of CVD Sic Ring

Processing / Surface Technology

Development

November Recertified as Venture Company

May Development and Mass Production of

Sapphire Plasma for HDP-CVD

Equipment Injector

December Received Gyeonge Governor Award (Excellent Venture December Export Frontier Co

Gumi New Buildin

June Patent Registratio

May

Manufacturing Ma

Business

April Certified as Parts March Semicon K

March Participated in Se Exhibition

04 · www.comatechnology.com

























2018

2019~CURRENT

gi Provincial

e Company)

ompany Certification

ocation of g (Area 10,000m²)

on (Sapphire Edge Ring ethod)

essful Export Package

Material Company orea Exhibition

micon Korea(Coex)

Won Gumi Mayor's Award for Clean December Management Act

October Designated as a Talent Development

Small Business

September Selected as Promising Export Firm

September Participated in Semicon Taiwan Exhibition

July Participated in Semicon West(USA)

Exhibition

Selected as a Partner of Hynix/Shared June

Growth Program

Participated in Semicon China(Shanghai) March

Exhibition

February Participated in Semicon Korea(Coex)

Exhibition

January Investment in Si Ring, Electrode Line **September** Participated in Semicon Taiwan Exhibition

August ISO9001&14001 Quality Environmental

Management Certification

July Selected as Mid Sized Start Up Leap

Package Business

MOU with GTAT to Enter US Semi Market June

Selected as Cloud Based Smart Factory May

R&D Project

March Participated in Semicon China(Shanghai)

Exhibition

Participated in Semicon Korea(Coex) January

Exhibition

January Development of Large Diameter

Sapphire Window 22"/23"

Attracted 2nd Investment from Domestic **January**

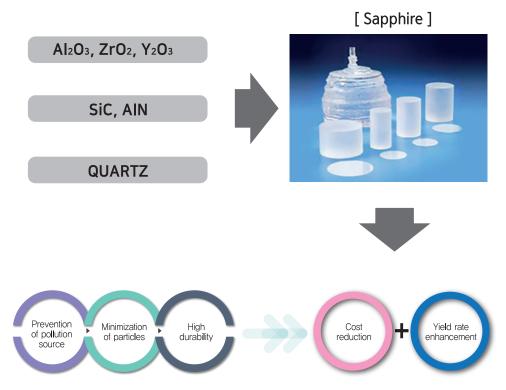
Asset Management Company



The Strongest Material on Earth after Diamonds

Sapphire is an ultra-high purity single crystal material, the second hardest material on earth after diamond, and the best existing material with heat resistance and chemical resistance at high temperature of 2040°C.

Market Flow of Process Parts



If sapphire is replaced with components made of Ceramics, Quartz, Silicon, etc., which are used in the semiconductor process, the yield is maximized by minimizing the generation of pollutants and particles in the deposition and etching process chambers during the semiconductor manufacturing process.

In addition, due to the high durability of the sapphire material, the component lifespan is increased and the replacement cycle is increased, making an innovative contribution to cost reduction.

▶ Sapphire Properties

HARDNESS

The Hardest Material on Earth after Diamond (Lift Pin)

HEAT RESISTANCE

Withstand 2040°C with No Change in Properties

CORROSSION RESISTANCE

Chamber Etching in Extreme NF3 and CF4 Gas Environment. (Gas Injector , Nozzle , Chamber Window)

CHEMICAL RESISTANCE

Radical Reaction does not Occur in Semiconductor Etch Process. Stable Molecular Structure Minimises Contanimation Inside the Chamber (Tube, Applicator)

INSULATOR

Very Stable Insulator that is Generated by Plasma in Process of the Chamber Minimising Arcing to Reduce Process Defects

▶ Sapphire Properties

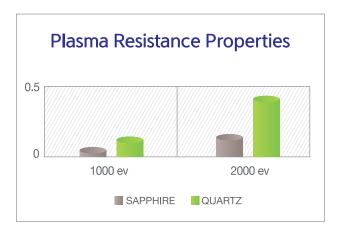
Physical Properties	Value		
Crystal structure	Hexagonal system (rhombohedral)		
Unit cell dimension	a = 4.758 Å , c = 12.991 Å		
Density	3.98g/cm²		
Hardness	9 mohs, 1,525-2,000 knoop		
Tensile strength	400Mpa		
Flexural strength	2,500~4,000Mpa		

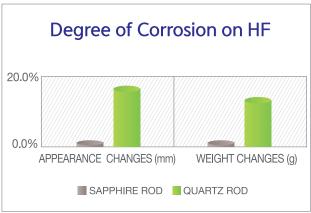
Thermal Properties	Value		
Thermal conductivity (at 300K)	23.1 W/m·k (perpendicular to c-axis) / 25.2 W/m·k (parallel to c-axis)		
Specific heat	105 J/kg.K at 91K / 761 J/kg.K at 291K		
Thermal coefficient of linear expansion (at323K)	6.66×10^{-6} /K(parallel to optical axis) 5.00×10^{-6} / K (perpendicular to optical axis)		
Melting point	2,050 ℃		
Boiling point	2,980 ℃		



► Why 'Sapphire'?

Sapphire is chemically durable, high strength, Material with high penetrability and is used in semiconductor process chambers as well as many other high vacuum applications. Recently, Quartz is rapidly replaced by Sapphire in demanding high vacuum fields. With many years of manufacturing experience in this field, Coma Technology aims to be the world's No. 1 in the Sapphire manufacturing market.



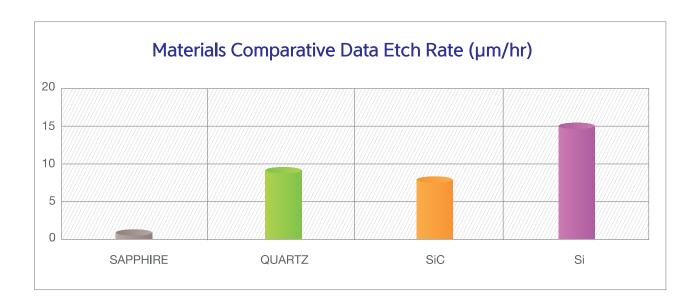


Ar+ Ion Energy	1000 ev	2000 ev
Sapphire	0.04	0.11
Quartz	0.13	0.4

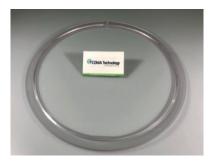
Ion Milling Rate: : Sapphire erodes at a rate of less than 1/3rd of Quartz

	Sapphire Rod	Quartz Rod
Appearance Changes (mm)	0.5%	16.2%
Weight Changes (G)	0.5%	13.3%

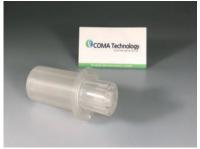
Measure the amount of variation after immersing for 12 hrs in 49% hydrofloric acid concentration



► Change to Sapphire



HOT EDGE RING FLEX 45 Si -> Sapphire

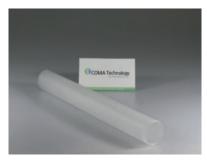


Al₂O₃, Y₂O₃ -> Sapphire



INJ, DUAL, FACSEAL, IEP, HNYCMB NOZZLE, AIN, 1.76L X .14DIA -N Al₂O₃, AlN -> Sapphire

► Sapphire Tube







▶ Sapphire Window













Nozzle/Injector(Ceramic -> Sapphire)

Coma Technology Co., Ltd. directly produces nozzles used in CVD & Etching process chambers during the semiconductor manufacturing process. In addition to the production of existing Al₂O₃, AlN, and Quartz materials, changing to Sapphire material minimizes the generation of pollutants and particles generated in the chamber to maximize the yield. In addition, due to the high durability of the sapphire material, the component lifespan is increased and the replacement cycle is increased, making an innovative contribution to cost reduction. Minimize particle generation in environments using NF3 and CF4, creating a long life and continuous working environment.

Gas flow(Less than 1%)



Ultima-x side nozzle, ALN, 1,76L x _020DIA, 100% flow Applied Materials (AMAT) Centura AP

Ultima×300mm HDP-CVD Al₂O₃, AlN → Sapphire

Sapphire + Sapphire



HPQ Injector NOZ, 8x, .055-45DE LAM Research 2300 Versys Kiyo Quartz, Al₂O₃ → Sapphire

Drastically longer lifespan



INJECTOR TUBE STAR INSERT 1,375

NOVELLUS SPEED HDP-CVD Al₂O₃ → Sapphire

Quartz + Sapphire



■ ENDPOINT, QTZ. W/SAPPHIRE WINDOW (Top hat, HPQ)

Applied Materials (AMAT) Centura AP Ultima×300mm HDP-CVD Al₂O₃, AlN → Sapphire







LAM / INJ, DUAL, FACSEAL, IEP, HNYCMB







AMAT / Side Noozle(All Dimensions Possible)







AMAT / NOZZLE INSERT DG 1.0 ID X 2.0L 300MM DPS



AMAT / Top Nozzle HDP CVD Ultima NOZZLE 4HOLE 60DEG, BAFFLE



OCOMA Technolog Sapphire

AMAT / 300mm HDP AIN 8 holes top nozzle Baffle





Silicon, widely used as semiconductor element material, is an excellent material that can be stably supplied to semiconductor industry as it is abundantly found in sand, rocks and ores in the oxidized form of SiO₂, Silicon has high purity single crystal structure of 99.9999% after purification process, and has strong durability, high functionality and high reliability by operating element in relatively high temperate (of up to approximately 200°C) due to low change in physical and mechanical properties according to temperature change.

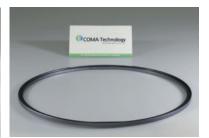
▶ 8" Silicon



TEL / Focus Inner Ring



TEL / Focus Ring



AMAT / Insert Ring



AMAT / Insert Ring



TEL / 6" Electrode



LAM / Electrode Silicon + Graphite Cathode

Silicon



Coma Technology Co., Ltd. has a full process production line for the production of Si–Ring and Si Electrode with 10–1000 Class Clean Room Facility.

▶ 12" Silicon



LAM / Hot Edge Ring



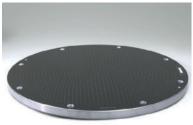
TEL / Focus Ring



AMAT / Collar Producer Etch Ring



TEL / Thin Inner Cell(738)



TEL / Electrode Cell(912)

Porous Vacuum Chuck

POROUS CERAMIC is a sintered body made of numerous pores by applying ceramic sintering technology, unlike conventional adsorption plates. Recently, it is widely used as a base material for various industries such as various filters, high temperature refractory materials, absorbent materials, sound absorbing materials, lightweight structural materials, and heat insulating materials. In particular, high performance vacuum chuck adsorption technology is used in the process of thin film adsorption required in the semiconductor, led and display production field. Coma Technology Co., Ltd. identifies the needs of Customers, and designs and produces the most suitable products for meeting their requirements.

▶ Why 'Porous Vacuum Chuck'?

- High Performance , High Precision & Uniform Adsorption
- Excellent Chemical Resistance against Acid and Alkali, High Heat Resistance
- No Hole Marks on Air Holes Due to Adsorption/floating
- Specific Gravity Lower than Aluminium
- Applicable in Various Fields According to Customer Needs

Film or Glass Porous Ceramic Vacuum Housing

► Why 'COMA Technology's Porous'?

- One Stop Process from Material Production > Design > Product Manufacturing
- Porosity /Pore Size Adjustable According to Customer Request
- Partial Adsorption Possible by Micro –Pore and Own Flow Path Design
- Proven Superior Durability Material
- Ensuring a flatness of 5um or less (Specifications can be discussed)

▶ Porous Vacuum Chuck Application Field

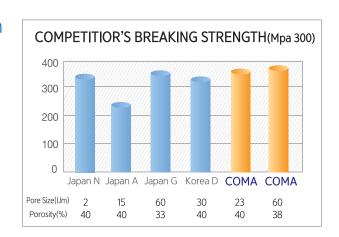
SEMICONDUCTOR	Grinding, Mount, Peeling Chuck, Dicing			
DISPLAY	Glass & Film Adsorption Dicing			
PCB	Multi Porous PCB Adsorption & Inspection			
LED	Wafer Adsorption, Inspection			
MACHINING	Back Grinding, Grinding /Polishing Machin For Adsorbing CNC Equipment Products			

CM-	- 01	CM-02		01 CM-02 CM-03		CM-04	
2um	40%	15um	40%	23um	40%	60um	38%

Porous Vacuum Chuck

► Coma Technology's Porous Product Specification

PORE SIZE	2~120um		
POROSITY	25~40%		
COLOR	Black , Brown and White		
ANTI STATIC	$10^6 \sim 10^9 \Omega$		
STANDARD	Maximum 22" (500*500)		

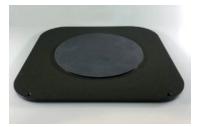


► Coma Technology's Products





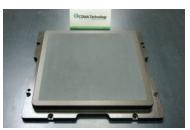




Glass/Film Adsorption







Multi-Use/Divided Adsorption







Quartz

Fused silica glass, commonly called quartz glass, is amorphous and has excellent properties. It has a very low thermal expansion rate, excellent thermal shock resistance, and excellent battery insulation, which is widely used in the semiconductor, aerospace, and energy fields.

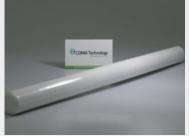
Coma Technology Co., Ltd. can manufacture various quartz products including quartz cover ring and semiconductor main parts consumables.



Groups of Various semiconductor Parts

Ceramic Plunger

The ceramic plunger manufactured by Coma Technology Co., Ltd. is manufactured with the close spec, within the world's only external tolerance of 2um and surface roughness Ra0.03. It has a lifespan of up to 5 times than of conventional metal plungers and is excellent for durability and leak prevention. Coma Technology Co., Ltd. is can manufacture plungers best quality by realizing perfect roundness, straightness and surface roughness value, also various types of orders can be made according to customer's requirements.











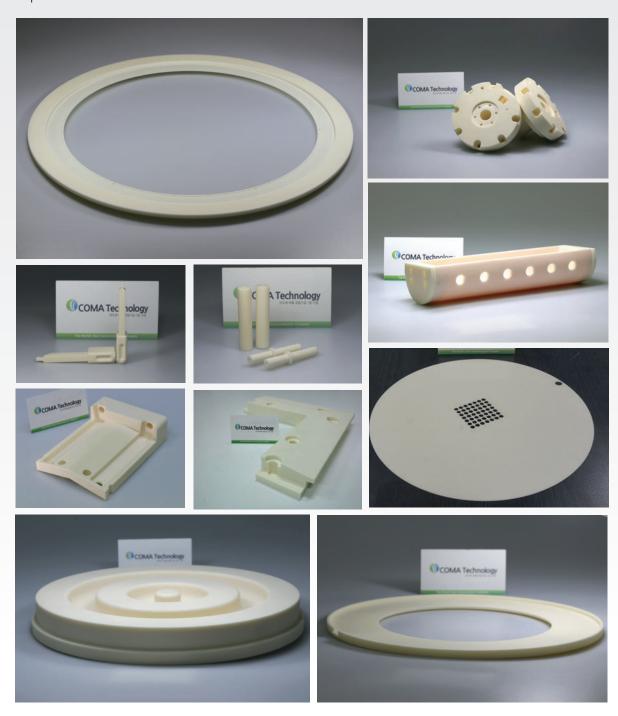






Alumina (Al₂O₃)

High purity alumina, with its excellent mechanical strength, heat resistance, abrasion resistance, and insulation, has a wide range of application areas not only on various electronic parts, semiconductor processes, spaceship, automobile engineering, but also human body bio-industry like bone implantation.



Groups of Various semiconductor Parts

Zirconia (ZrO₂)

Zirconia is a kind of fine ceramics. Which is very close to metal and can be replaced by complementing the shortcomings of metals due to its excellent mechanical properties.



Silicon Carbide (SiC)

SiC materials have high thermal conductivity, hardness, plasma resistance, oxidation resistance, abrasion resistance, corrosion resistance, high temperature stability and thermal shock resistance.



A Company to Create a New Structure in the Global Market of Semiconductor Industry!



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